

Radiation measurements

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Sensor or detector is a device that detects the physical properties of objects and gives an electronic signal

Input: electromagnetic radiation

Output: electronic signal that is converted to human-readable display

Physical effects which are frequently used for detection:

- ionization rate
- properties of the atomic excitation
- electronic conductivity in crystals
- light production, etc.

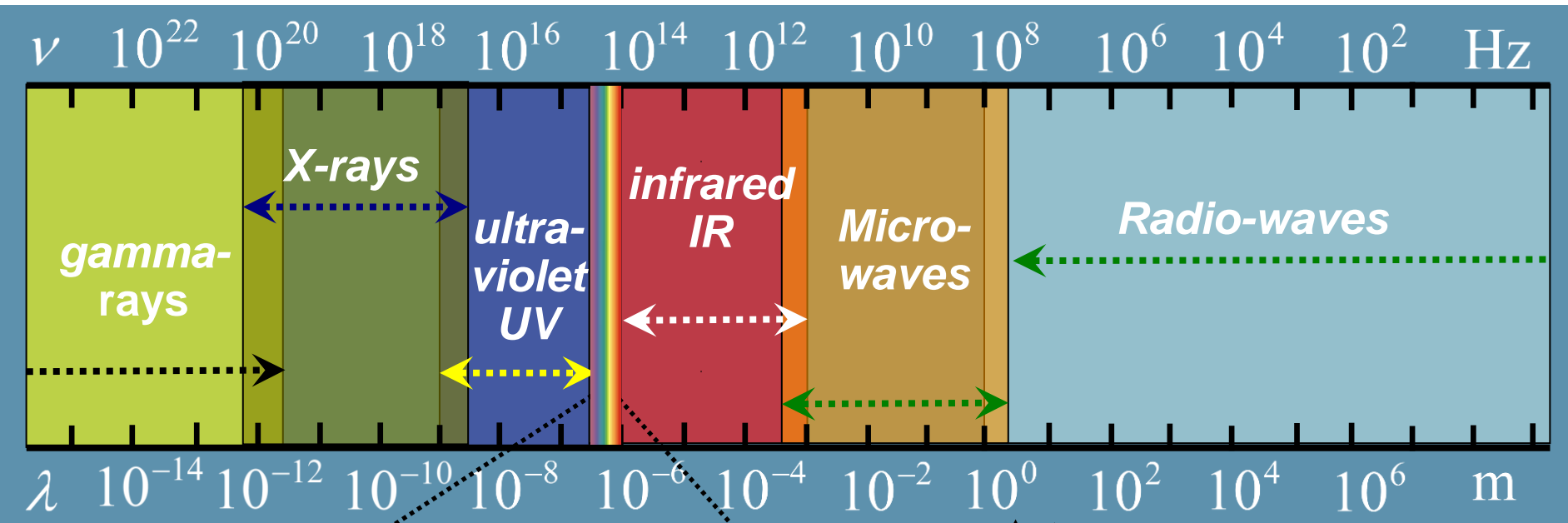


Nuclear radiations: charged particles, EM radiation (gamma-, X-ray), beta-particles, alpha-particles, ions

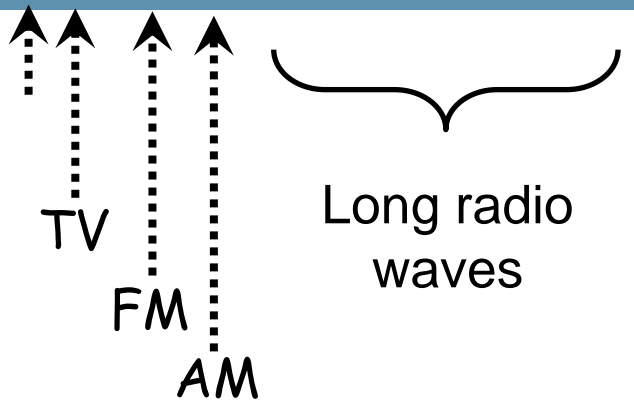
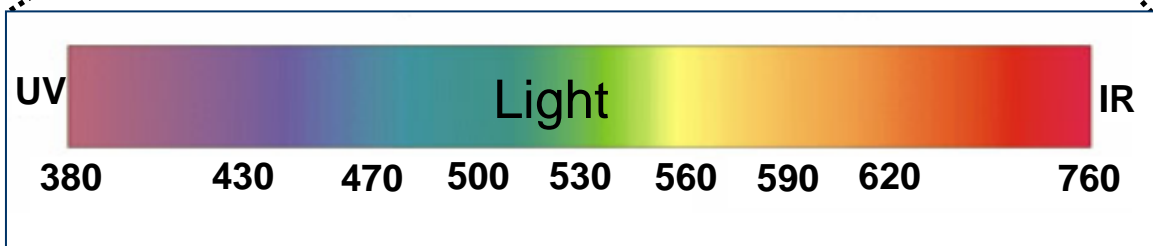


Detection of nuclear radiations by interactions between photons/particles and matter \Rightarrow producing electrons and/or light

Spectral distribution of electromagnetic (EM) radiation

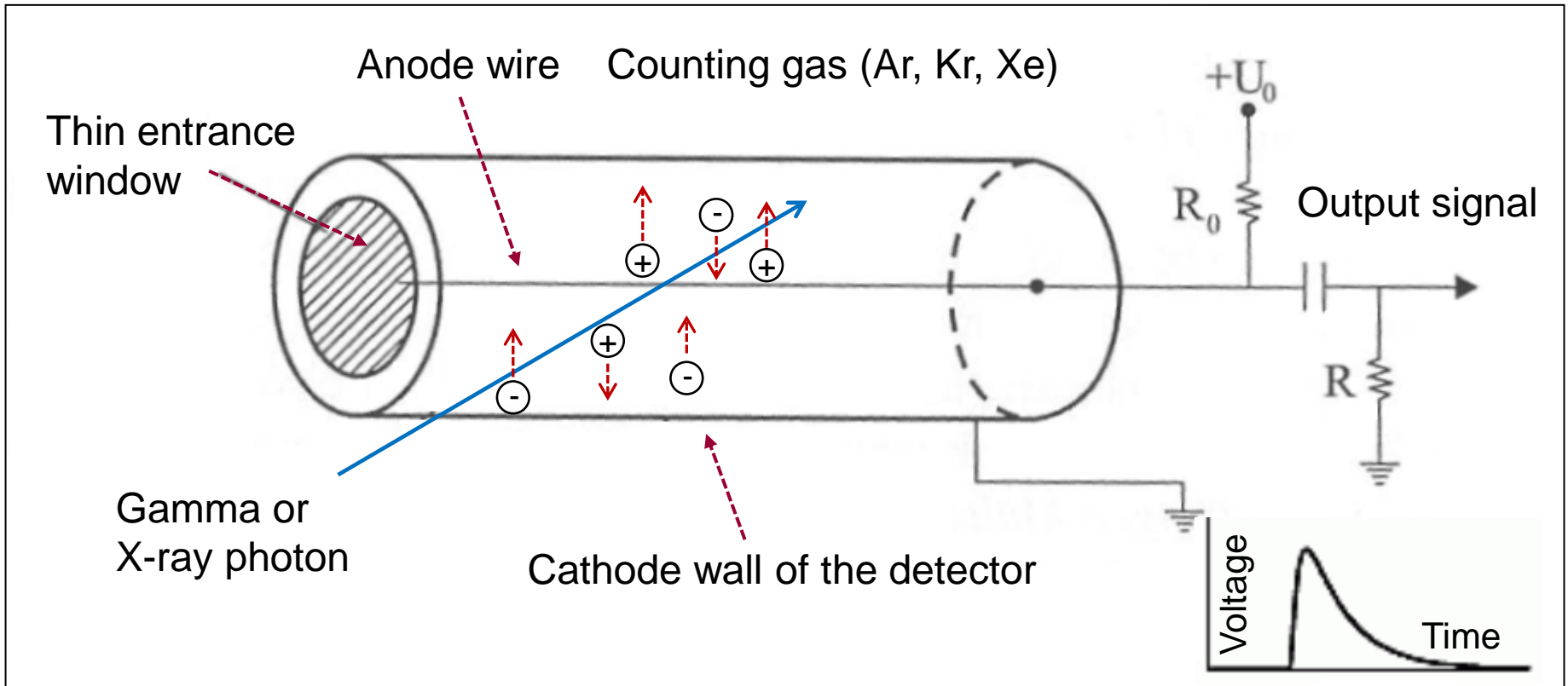


$1 \text{ \AA} = 0.1 \text{ nm}$
 $10^3 \text{ nm} = 1 \mu\text{m} = 10^{-6} \text{ m}$

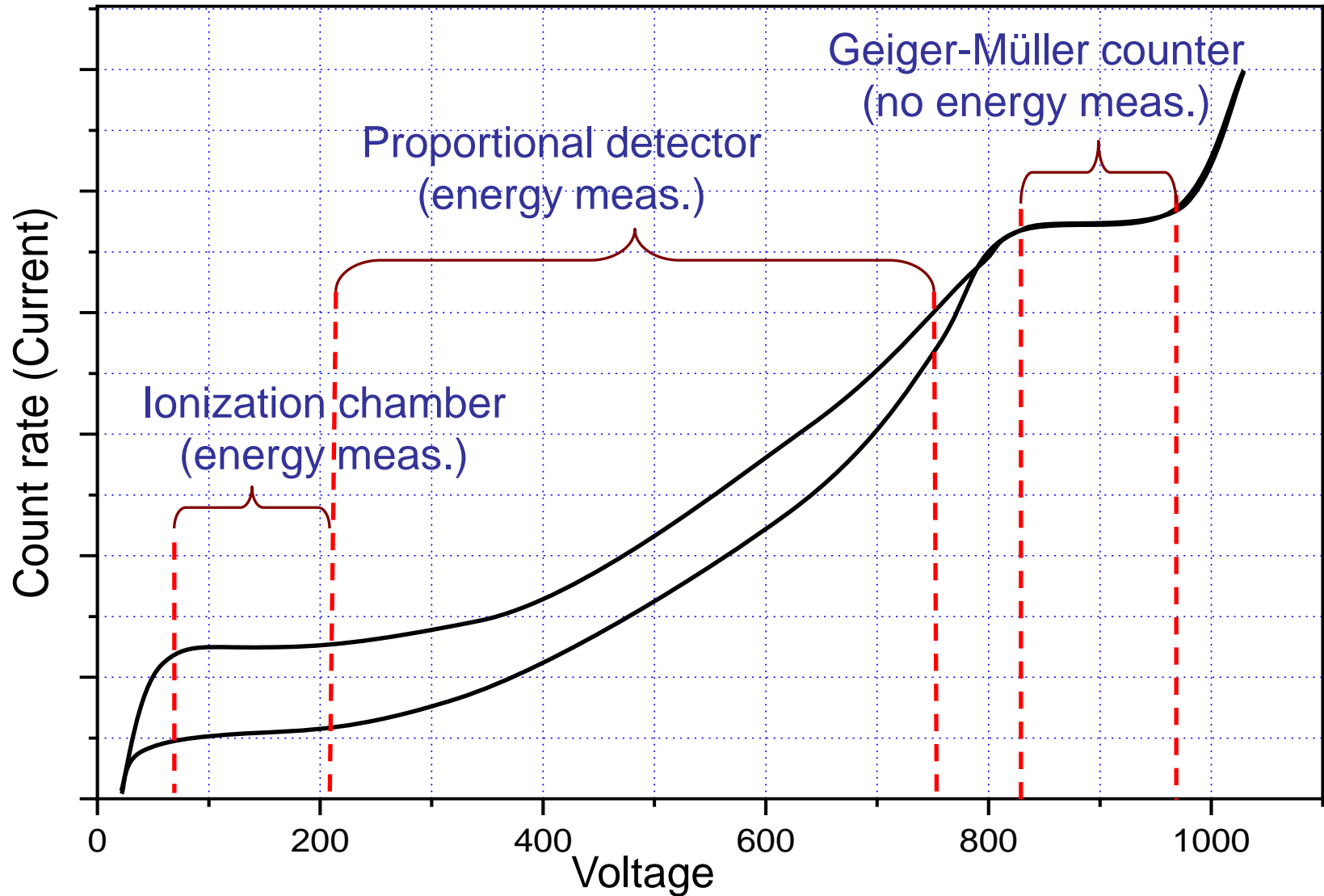


Gas-filled detectors

- Ionization and excitation of gas atoms/molecules along the particle trajectory \Rightarrow positive ions and free electrons
- External electric field \Rightarrow (-) charged move to anode and (+) to cathode \Rightarrow production of electronic signal $\Rightarrow U_{\text{anode}}(t) \Rightarrow$ electric pulse



Characteristic properties of the electronic signal (output) in gas-filled detectors (constant ionization effect)

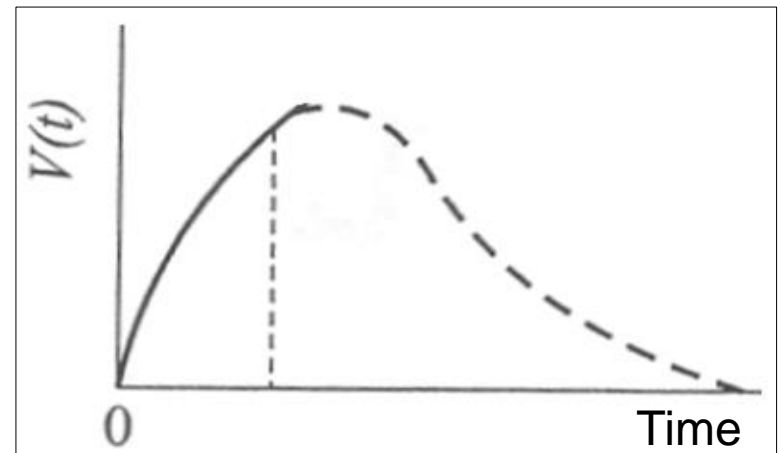


Gas-filled detectors

- First electronic sensor measuring ionization radiation
- Development: first half of the 20th. century
- Simple structure and electronics \Rightarrow low cost
- Suitable to measure α (He), β (electron or positron), γ and X radiations



- Energy measurements \Rightarrow integral of the output electric signal



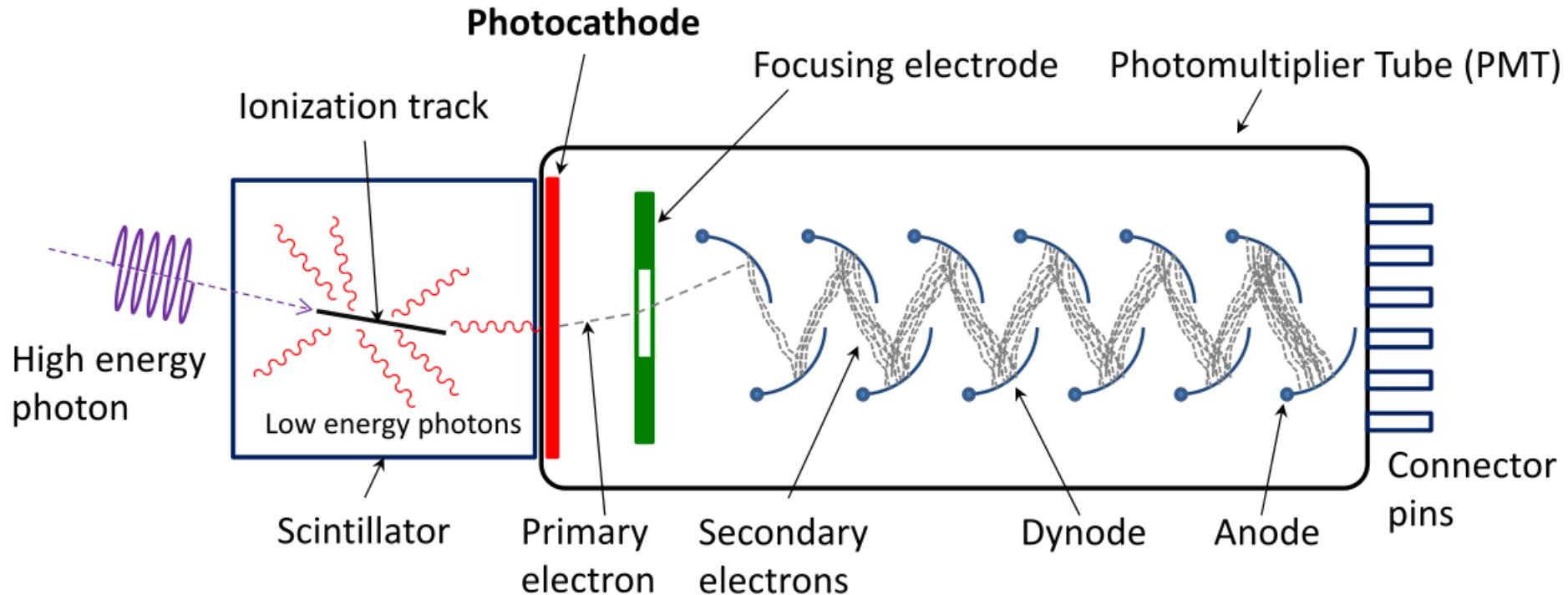
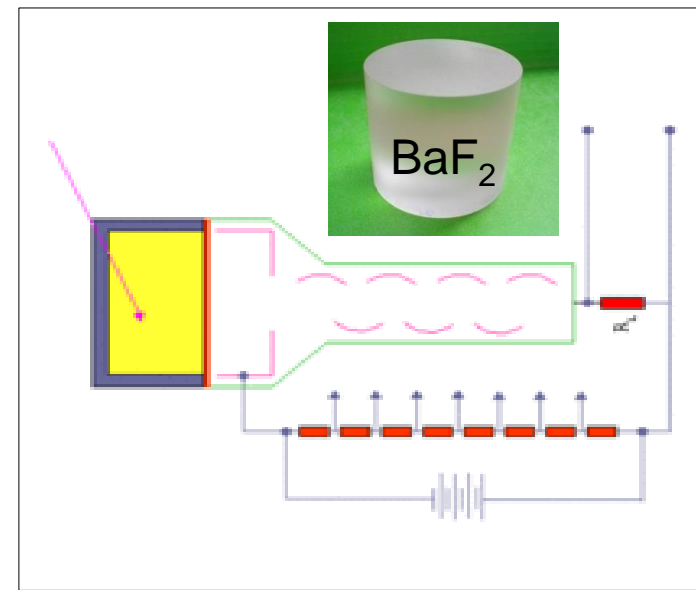
Dose measuring gas-filled detectors

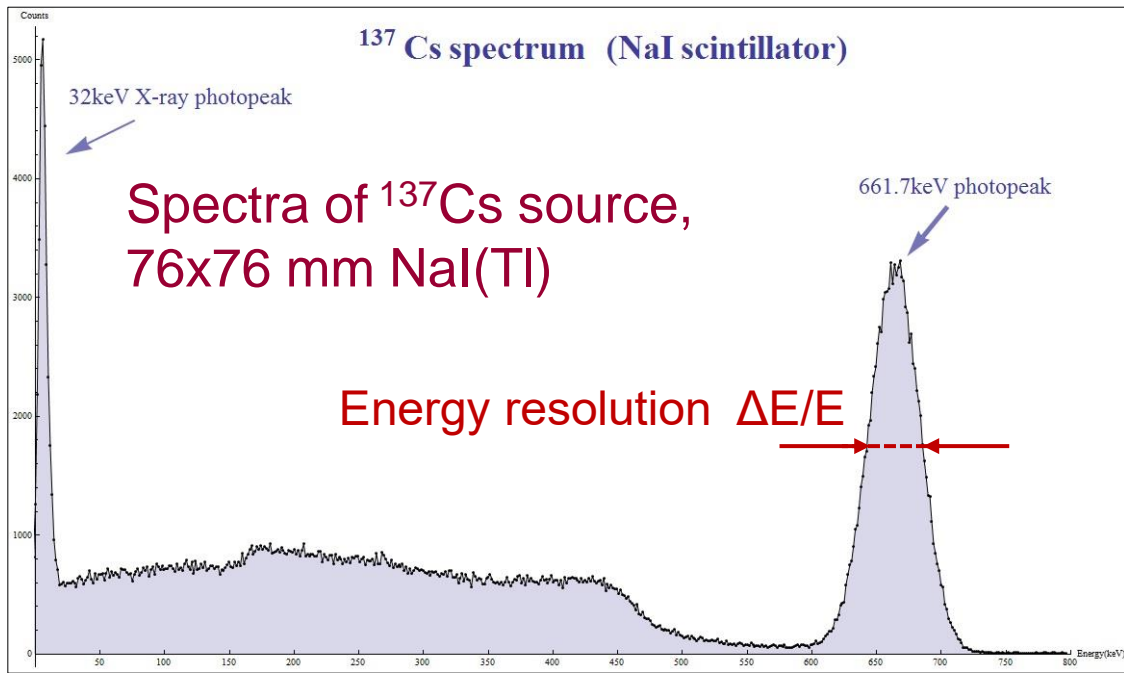
- W = average energy loss per ion pair formed in gas
- S = energy loss of the radiation in the material to that gas
- P = number of ion pairs per unit mass formed in the gas
- D = absorbed dose $\Rightarrow D = WSP$



Scintillation detectors

- ZnS + ionization radiation (charged particles, EM) \Rightarrow light emission
- 1940s \Rightarrow luminosity is proportional to the absorbed energy
- What material is suitable as a scintillator?
- Inorganic, organic materials, liquid and gas.

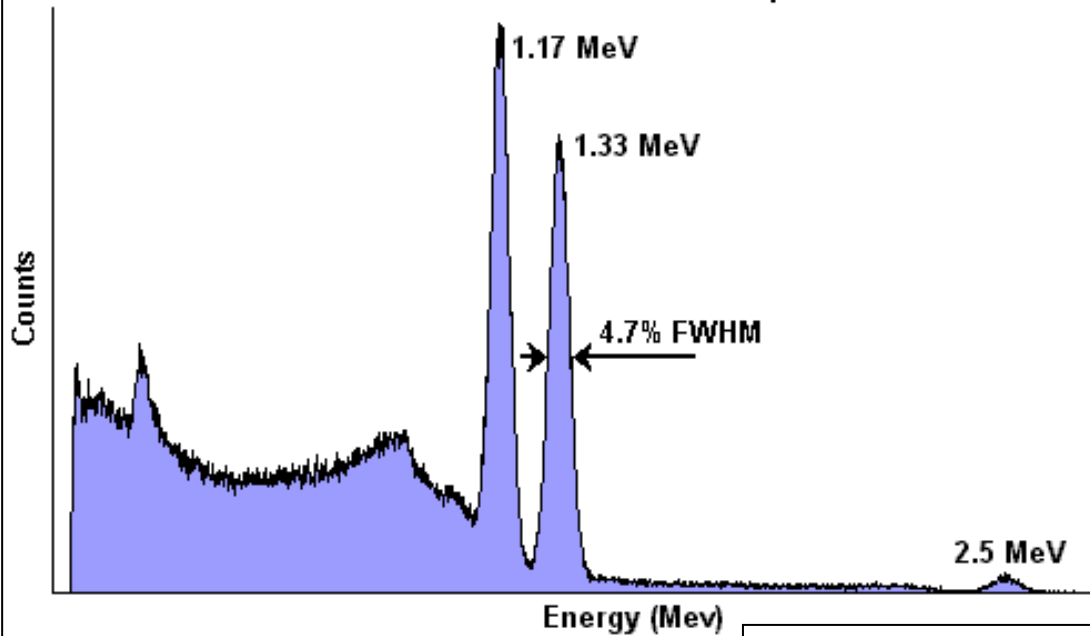




Physical properties of inorganic scintillator materials

| Material | NaI(Tl) | CsI(Tl) | $\text{Bi}_4\text{Ge}_3\text{O}_{12}$ |
|------------------------------------|---------|---------|---------------------------------------|
| Density (g/cm^3) | 3.67 | 4.51 | 7.13 |
| Time constant (ns) | 230 | 1000 | 300 |
| Luminescence wavelength (nm) | 420 | 565 | 480 |
| Relative light intensity | 100 | 45 | 7-10 |
| Refractive index | 1.85 | 1.78 | 2.15 |

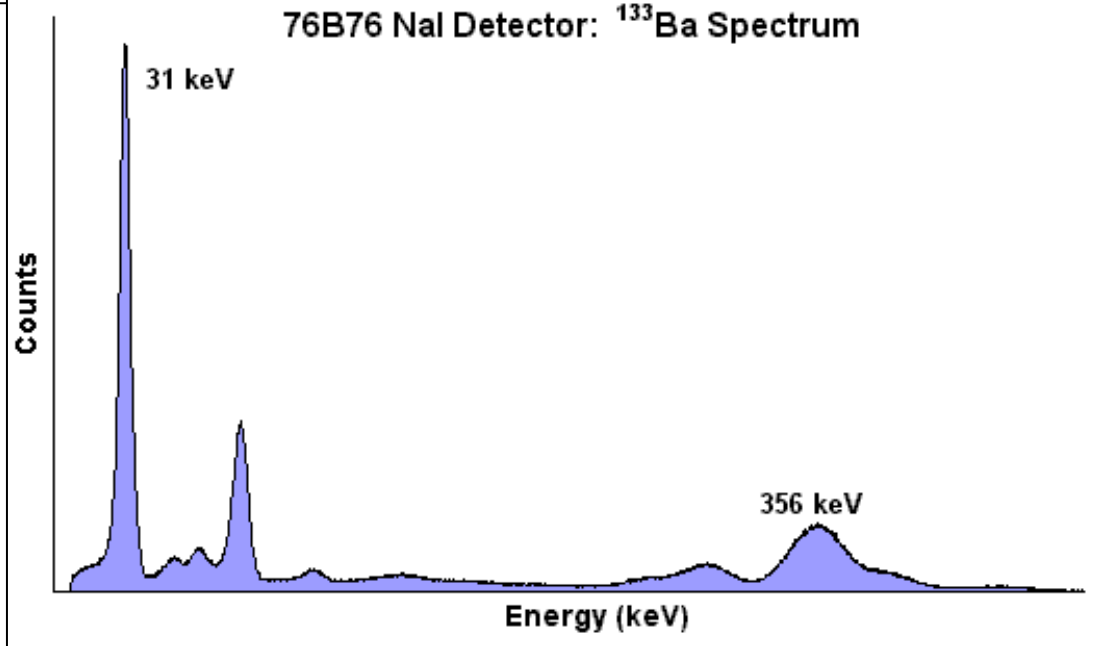
76B76 NaI Detector: ^{60}Co Spectrum



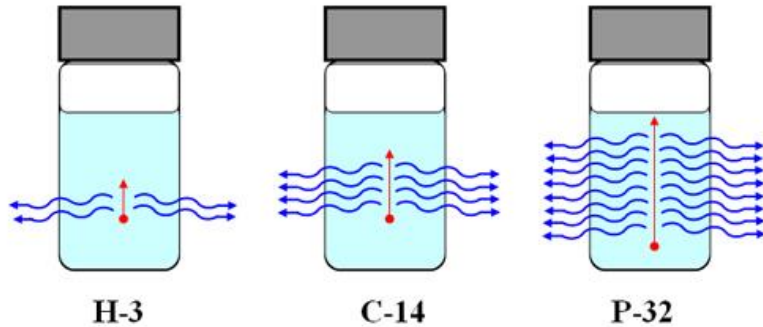
Gamma spectra
measured by
scintillation detectors



76B76 NaI Detector: ^{133}Ba Spectrum



Liquid Scintillation Spectroscopy (LSC)



^3H $E_{\text{max}}=18.6 \text{ keV}$ \Rightarrow ≈ 30 photons

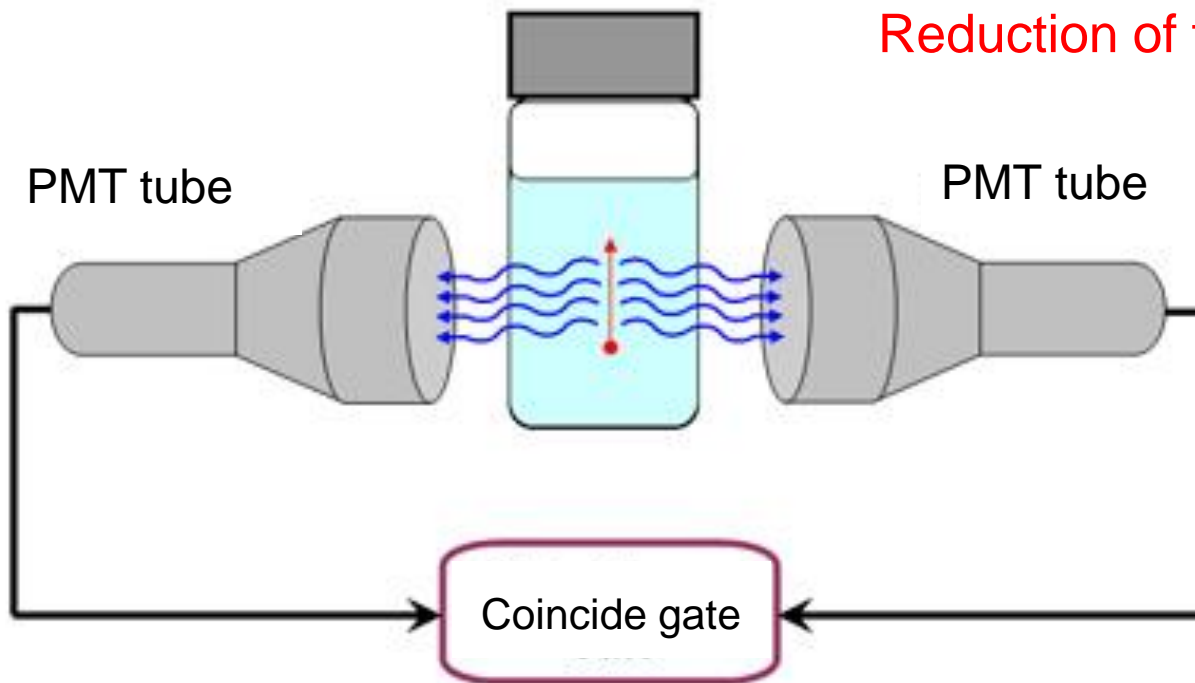
^{14}C $E_{\text{max}}=156 \text{ keV}$ \Rightarrow ≈ 250 photons

^{32}P $E_{\text{max}}=1,71 \text{ MeV}$ \Rightarrow ≈ 3300 photons

Low fluorescence yield \Rightarrow $\approx 1\%$ of the β energy is converted into light.

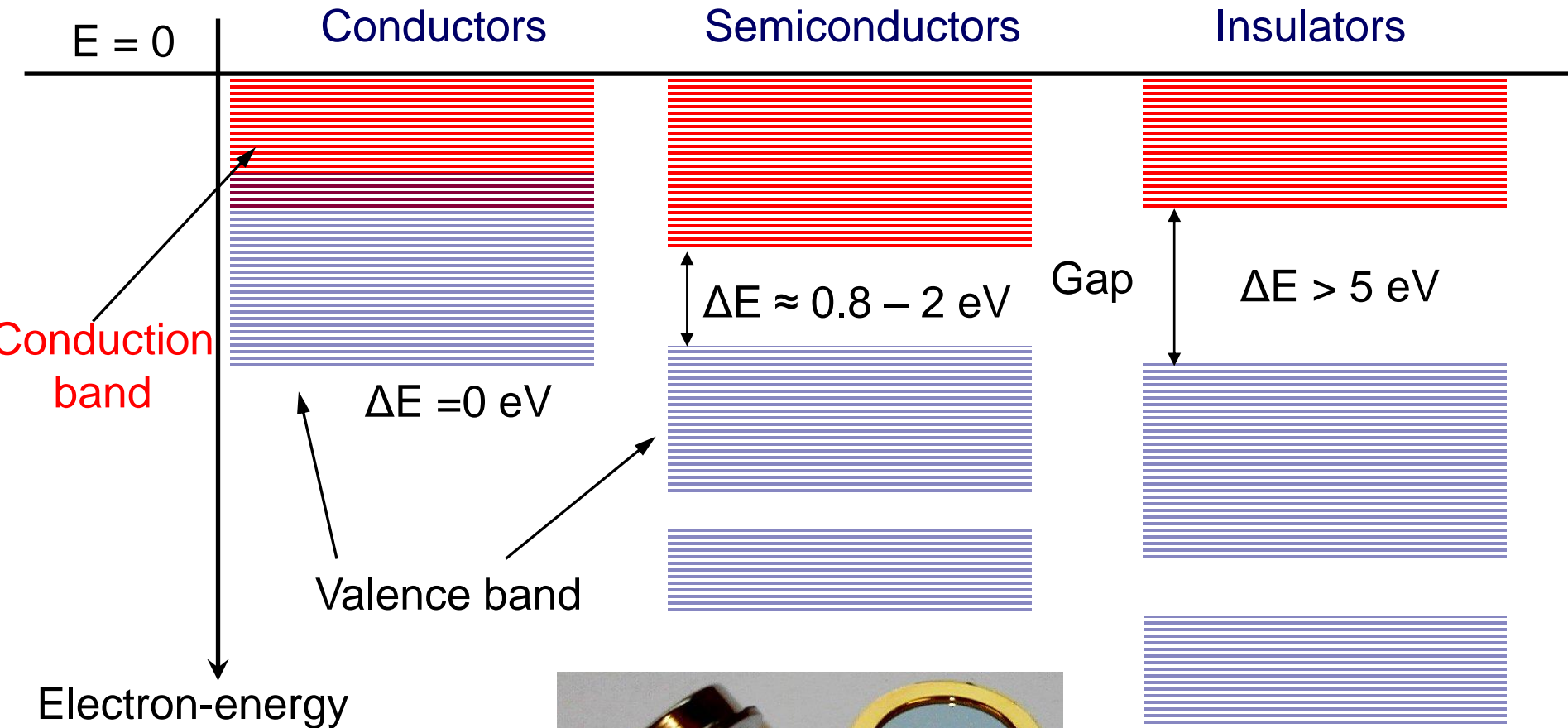
Reduction of the noise is necessary!

Toluene, xylene,...

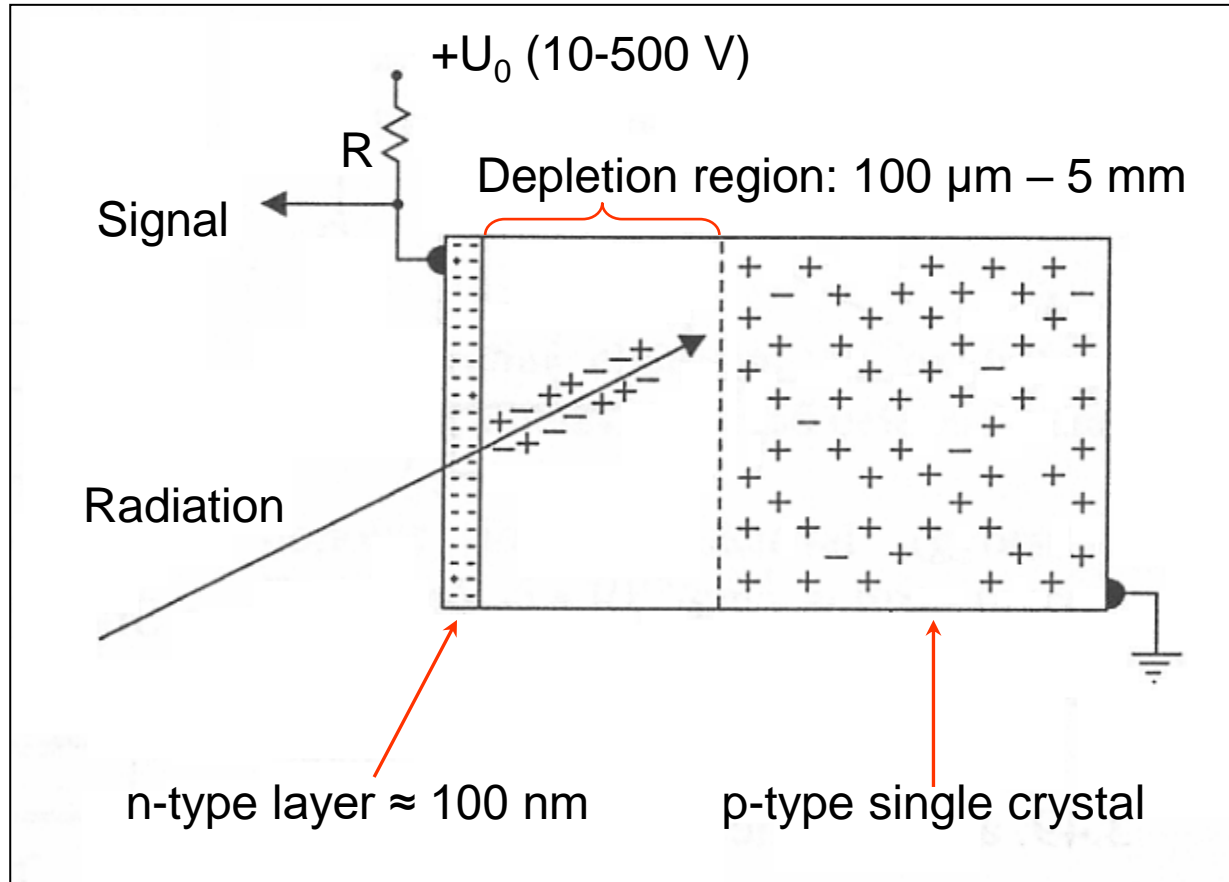


Semiconductor detectors

Band structure of solid materials



General structure of semiconductor detectors

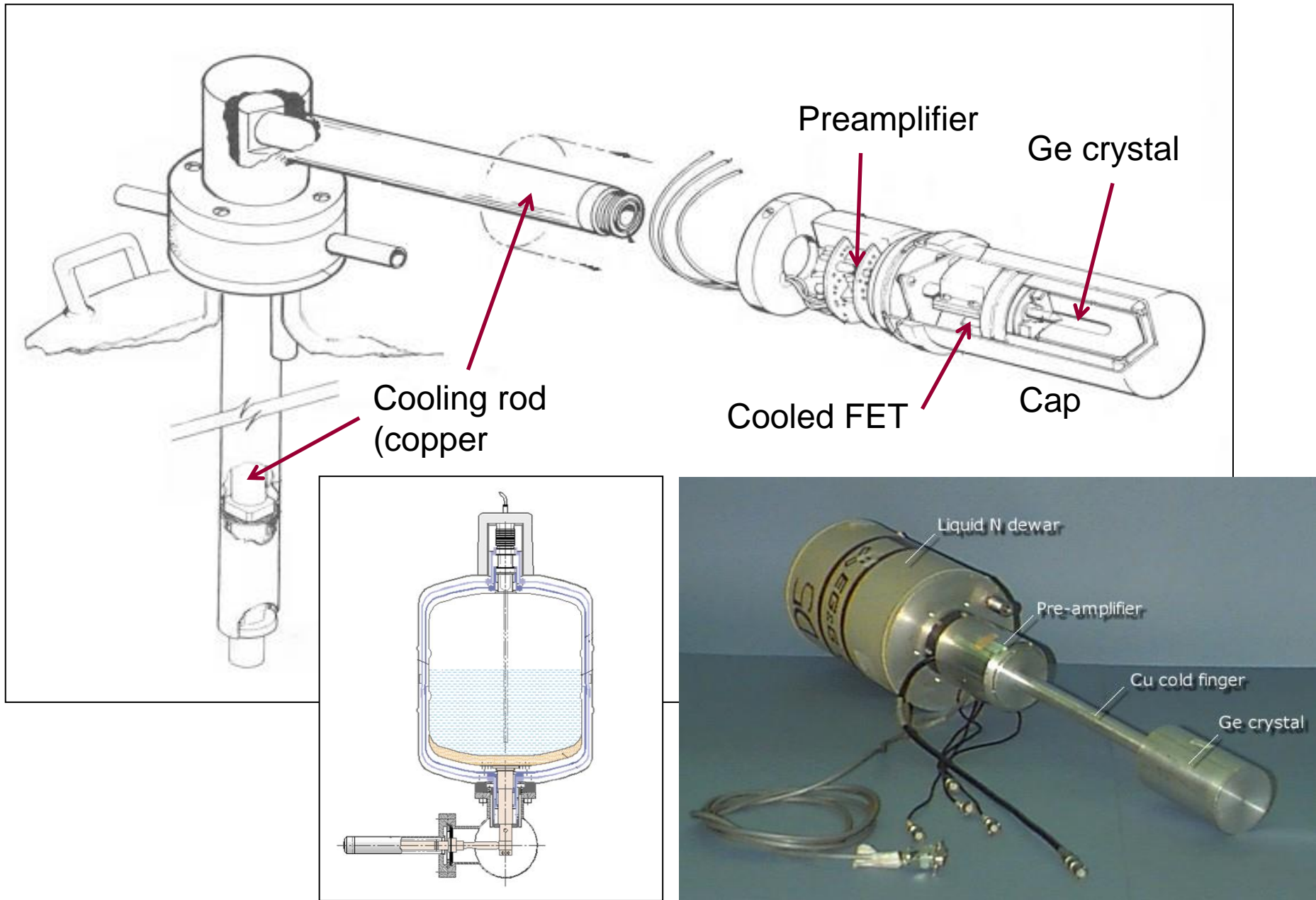


- Electrode: Au layer
- Ion implantation
- p-n junction
- High volume space charge region
- Sensitive volume: 0.2 – 50 mm

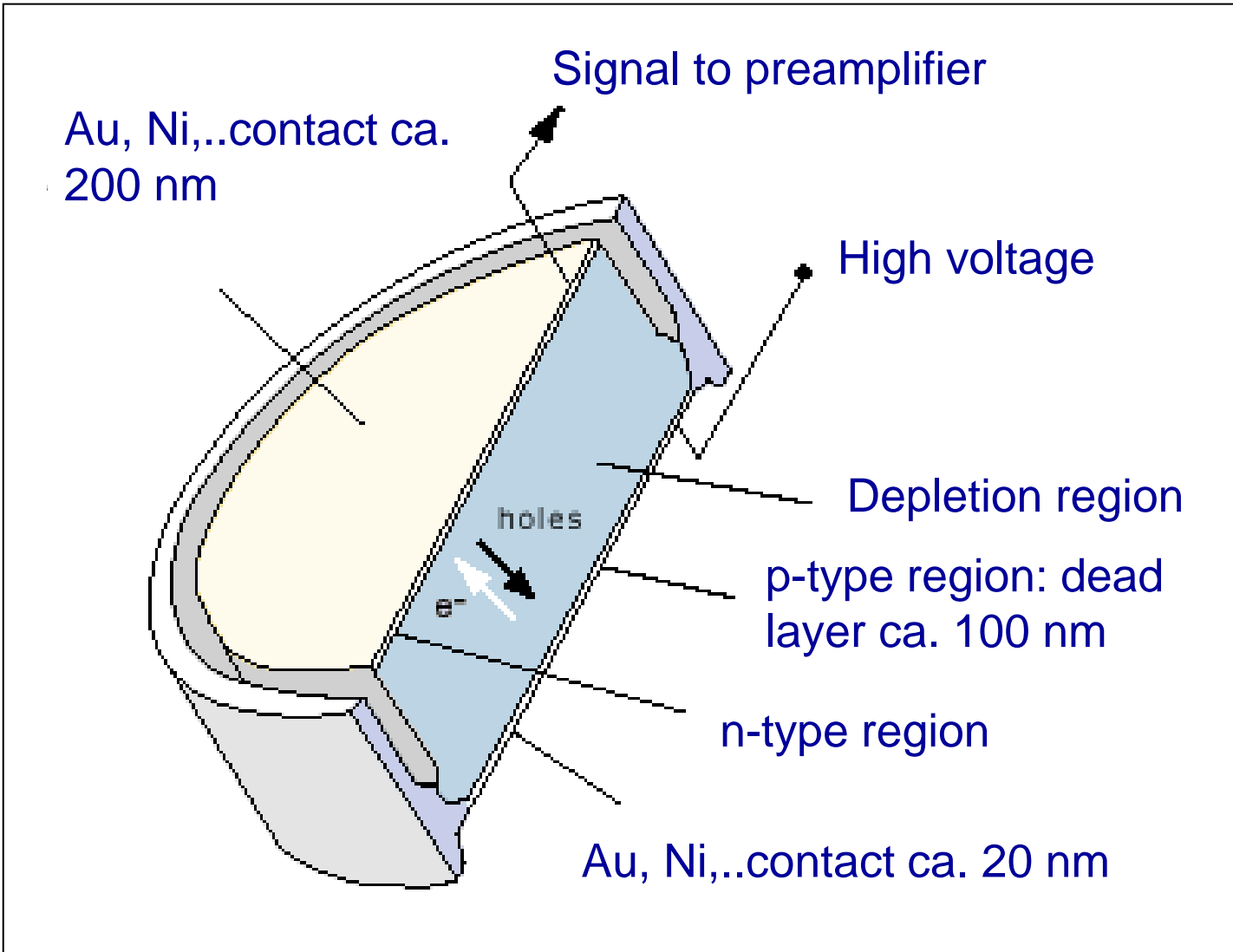
- Cooling is necessary to decrease the thermal noise
- T = 92 K liquid nitrogen temperature
- Peltier-type cooling system
- Charge collection time: 10⁻⁷ – 10⁻⁸ s



Structure of HPGe detector cooled with LN₂



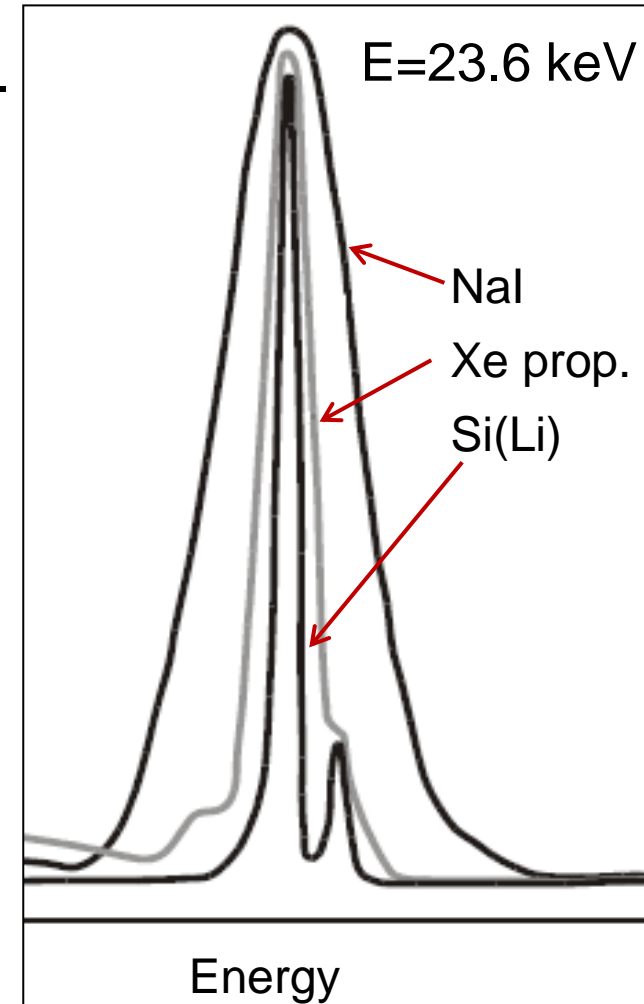
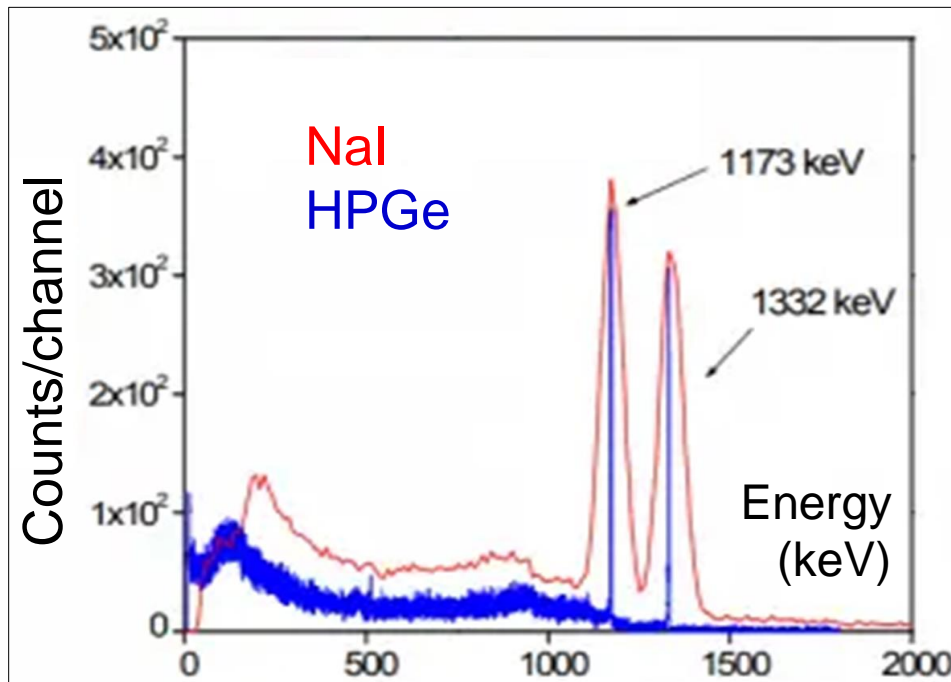
Si(Li) and Silicon Drift detectors for X-ray measurement



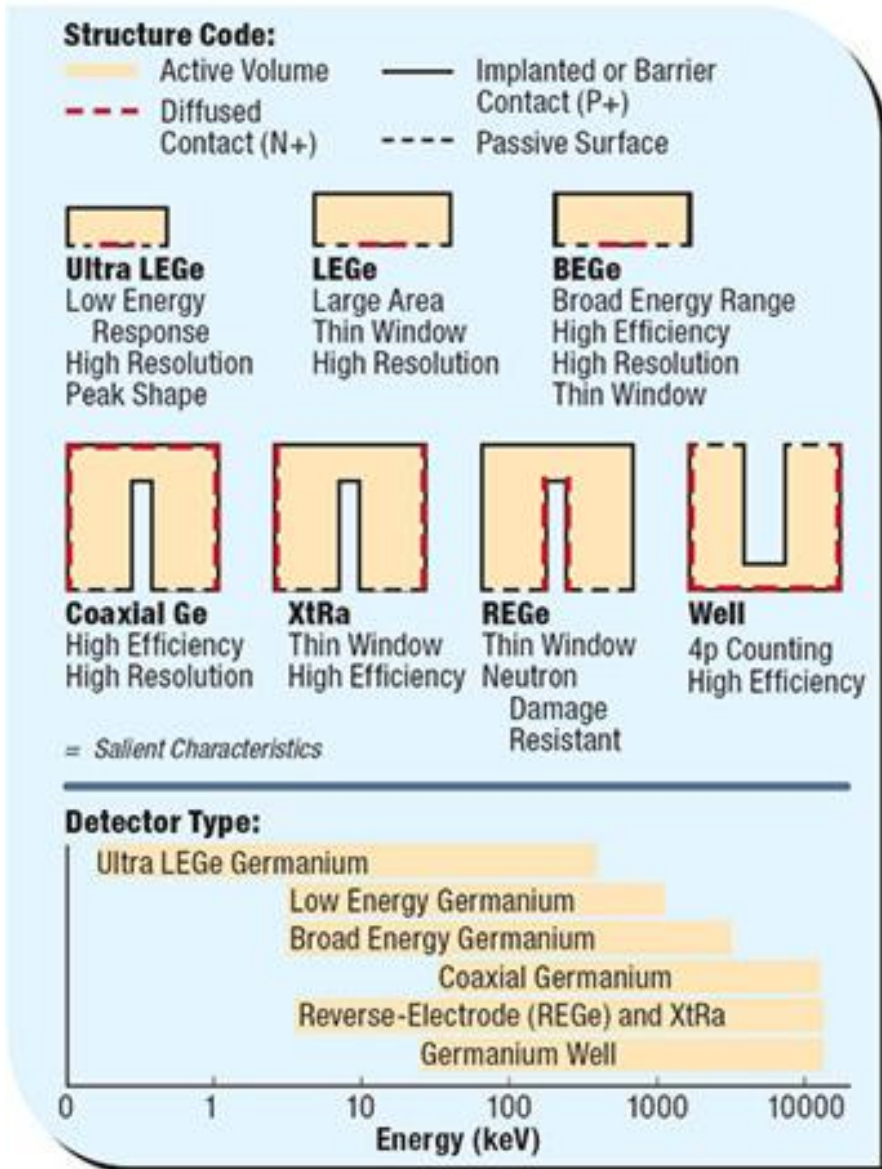
Si(Li) $\Delta E \approx 125 \text{ eV}$, $E = 6.4 \text{ keV}$, Max. count rate $\approx 20 - 50 \text{ kcps}$

General properties of semiconductor detectors

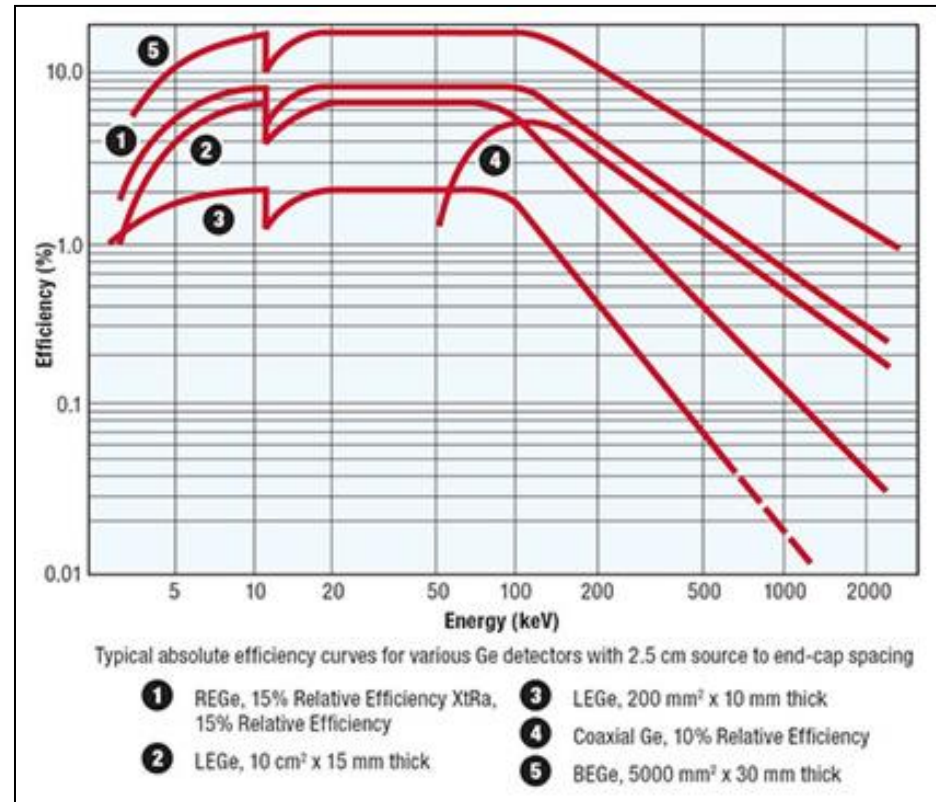
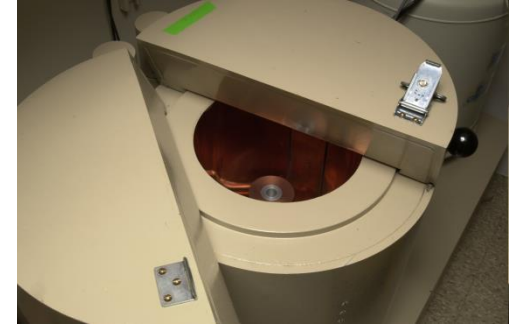
- Solid material \Rightarrow higher density \Rightarrow higher excitation probability
- Higher density compared to the gases \Rightarrow higher detection efficiency
- Operation in atmospheric and vacuum condition
- First applications: 1960, Si, Ge, CdTe, HgI₂,....
- Short response time: \approx ns!!!
- Energy resolutions



Usual geometry of HPGe detectors

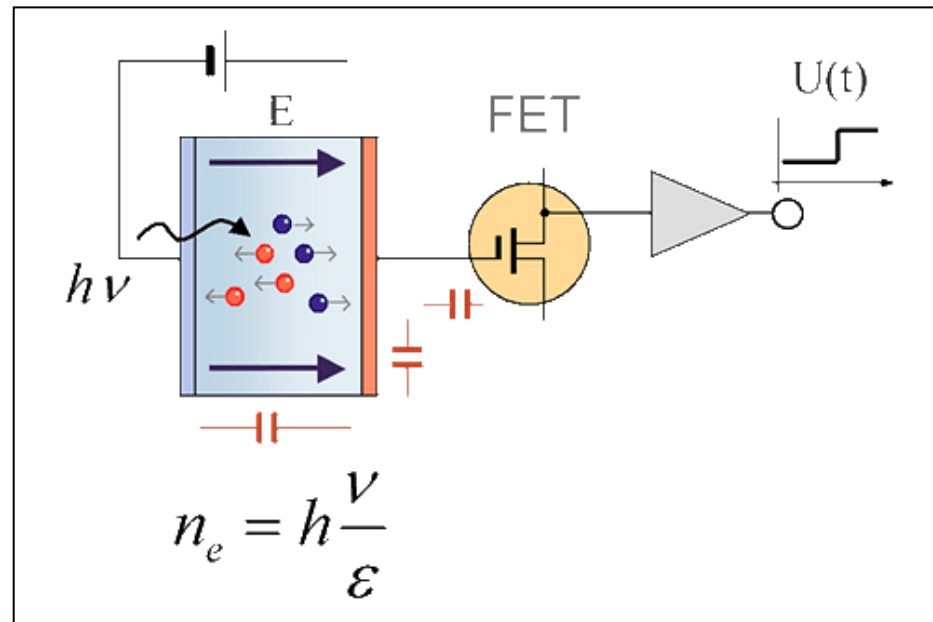
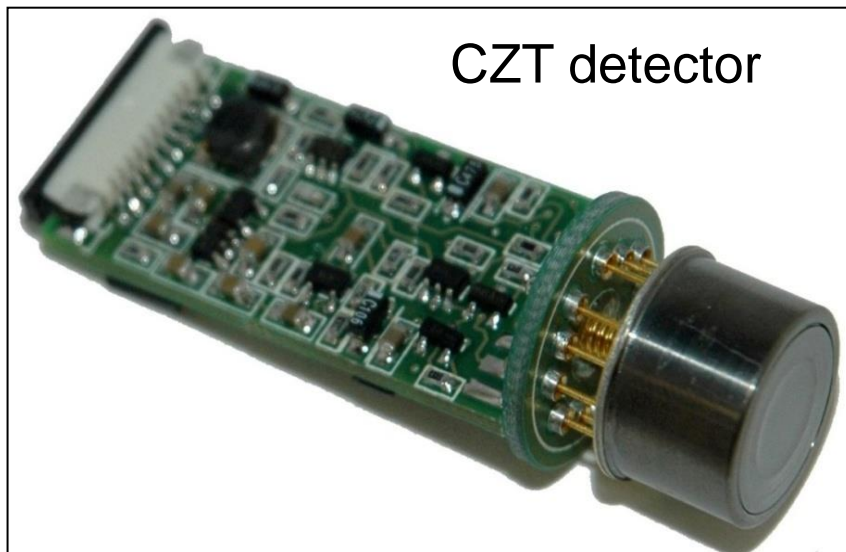
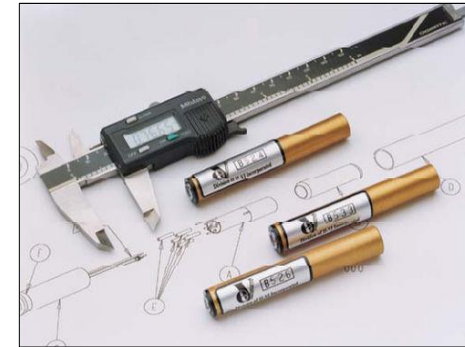


- Coaxial Ge
- Well
- Planar
- REGe



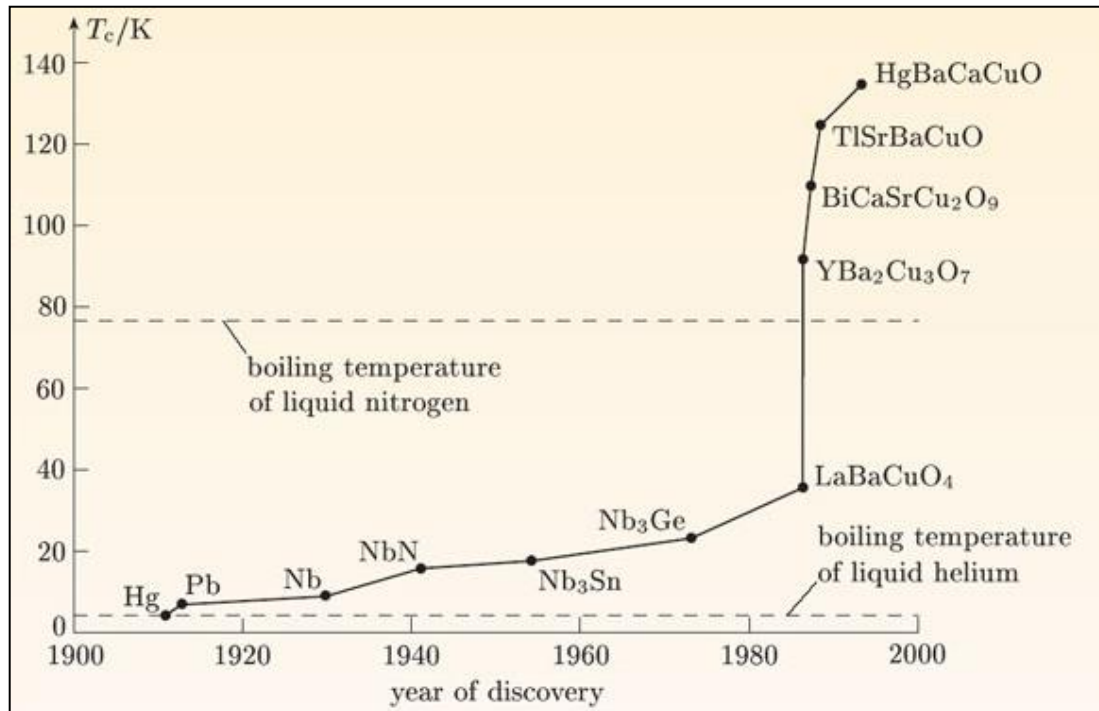
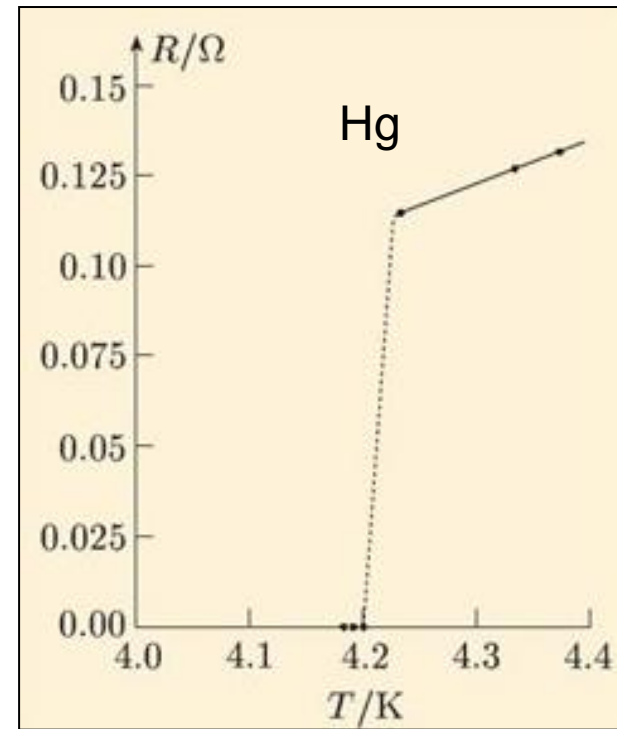
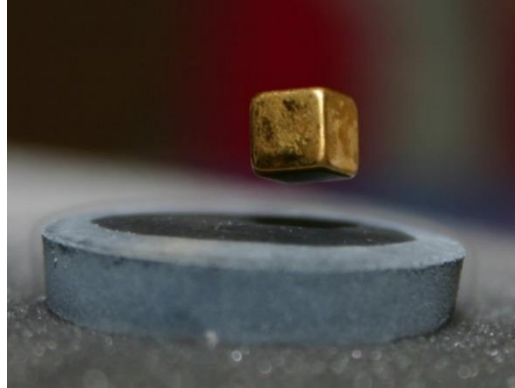
Si PIN and CZT (CdZnTe) detectors

- $10^2 - 10^4$ times lower mass and volume than HPGe
- Low efficiency on high energy
- Operate at $T = -40$ - 50 °C, room temperature (!)
- Extreme conditioning: space, Mars, underground deep
- High count rate without loss of resolution
- Cheap manufacturing
- Integral design on a single chip



Superconducting detectors

- Temperature dependence of electrical resistivity
- Meissner-effect
- Critical magnetic field



| Conductor | Crit. Temp. (K) |
|-----------|-----------------|
| Zn | 0.79 |
| Ga | 1.1 |
| Al | 1.14 |
| Sn | 3.69 |
| Hg | 4.17 |
| V | 4.29 |
| Pb | 7.26 |

Superconductor detectors

- Superconductive Tunnel Junction = STJ

- Cooper-pairs

- $E_{\text{binding}} \approx 1\text{-}2 \text{ meV}$

- **FWHM $\approx 5\text{-}15 \text{ eV}$**

$$E = 100 \text{ eV} < E < 10 \text{ keV}$$

- Count rate: $< 100\text{-}200 \text{ cps}$

- Cooling: He, N₂

- Surface $\approx 140 \times 140 \mu\text{m}^2$

$$\frac{\Delta E}{E} \sim \frac{1}{\sqrt{N}} \quad E_{\text{Cooper}} = 1.76kT_c$$

$$\Rightarrow E_{\text{Cooper}} \approx 10^{-3} - 10^{-5} \text{ eV}$$

